

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Mitsuru ISHIKAWA et al.	) Group Art Unit: 1792
Application No.: 09/696,232	) ) Examiner: Allan W. Olsen
Filed: October 26, 2000	) Confirmation No.: 5127
For: ETCHING METHOD	)
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	
Sir:	

## **REQUEST FOR RECONSIDERATION**

In reply to the Office Action mailed March 31, 2008, the period for response to which extends through July 31, 2008, by a request for extension of one month and fee payment filed concurrently herewith, Applicants respectfully request reconsideration of the application in light of the following remarks:

Remarks/Arguments begin on page 2 of this paper.